



Sheet 1 of 1

FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTORNEY DOCKET NO. 1572.1243	APPLICATION NO. 10/820,748
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		FIRST NAMED INVENTOR Je-Hyoung RYU, et al.	
		FILING DATE April 9, 2004	GROUP ART UNIT 2829

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
VN	AA	5,744,863	4/28/98	Culnane et al.			
	AB						
	AC						
	AD						
	AE						
	AF						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	TRANSLATION YES NO		ENGLISH ABSTRACT
VN	AG	2002-0087227	11/22/02	Republic of Korea		X	X
VN	AH	2002-0078718	10/19/02	Republic of Korea		X	X
VN	AI	2000-0052405	8/25/00	Republic of Korea		X	X
VN	AJ	1999-000619	01/15/99	Republic of Korea		X	
VN	AK	2002-0061468	07/24/02	Republic of Korea		X	
	AL						

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

TRANSLATION
YES NO

	AM		
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EXAMINER

DATE CONSIDERED

08/26/05

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



ATTACHMENT 1(g)

LIST OF ADDITIONAL SUBMITTED DOCUMENTS	ATTORNEY DOCKET NO.	APPLICATION NO.
	1572.1243	10/820,748
	FIRST NAMED INVENTOR	
	Je-Hyoung RYU, et al.	
	FILING DATE	GROUP ART UNIT
	April 9, 2004	2829

The following document(s) is/are listed in accordance with the duty of disclosure provisions of 37 CFR § 1.56, so that the Examiner may consider same should he deem any thereof to be material to examination of the subject application.

It is requested that the Examiner acknowledge his consideration of document(s) below-listed by initialing same in the space provided adjacent each such application and that the Examiner sign and date this form at the bottom thereof to confirm such consideration having been given.

This submission in no way represents an admission that any of the information listed herein constitutes prior art with respect to the subject application; and unless and until such prior art status is established, this submission is not a request that the information presented herein be printed on the face of any patent issuing from the subject application in which this information is being filed.

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	AA						
	AB						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO	
	AC							
	AD							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

						TRANSLATION YES NO	
VN	AE	Korean Office Action issued on July 12, 2005					X

EXAMINER <i>anh Nguyen</i>	DATE CONSIDERED <i>08/26/05</i>
*EXAMINER: Initial if document considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

ATTACHMENT 1(e)

EXPLANATIONS OF RELEVANCY OF REFERENCES	ATTORNEY DOCKET NO. 1572.1243	APPLICATION NO. 10/890 748
	FIRST NAMED INVENTOR Je-Hyoung RYU, et al.	
	FILING DATE April 9, 2004	GROUP ART UNIT 28 29

- VN* Reference AG (KR 1999-619) is entitled "Preventing Heating Up of Semiconductor Tester."
- VN* Reference AH (KR 2002-61468) is entitled "Contractor of the Device for Testing Semiconductor Element."

anh Nguyen

08/26/05